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Optics and optical instruments — Optical transfer function — Principles and procedures of measurement iTeh STANDARD PREVIEW

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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

Draft International Standards adopted by the technical committees are circulated to the member bodies for voting. Publication as an International Standard requires approval by at least 75 % of the member bodies casting a vote.

Superior Standard SO 9335 was prepared by Technical Committee ISO/TC 172, Optics and optical instruments, Subcommittee SC 1, Fundamental standards.

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Introduction

The optical transfer function is an important aid to objective evaluation of the image forming capability of optical, electrooptical and photographic systems.

In order that optical transfer function measurements achieved using different measuring principles or obtained from measuring instruments in different laboratories can be compared it is necessary to ensure equivalence of measurement parameters such as focus setting and spatial frequency range. For this reason, an agreed terminology has been defined in order that the measurement parameters called upon in this International Standard can be understood by all users. This International Standard gives guidance for the construction and operation of equipment for optical transfer function measurement.

transfer function measurement. **iTeh STANDARD PREVIEW** The specifications in this International Standard form the basic requirements of measurement instrumentation and procedures for guaranteeing1) a defined accuracy of measurement of the optical transfer function.

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Optics and optical instruments — Optical transfer function — Principles and procedures of measurement

1 Scope

This International Standard gives general guidance for the construction and use of equipment for measurement of the optical transfer function (OTF) of imaging systems.

This International Standard specifies important factors that can influence the measurement of the OIF, and RD 3 Definitions gives general rules for equipment performance requirements and environmental contros standards.iteh.ai) For the purposes of this International Standard, the

It specifies important precautions that should be taken definitions given in ISO 9334 apply. to ensure accurate measurements and specifies cor 35:1995 rection factors to be applied to the collected datastandards/sist/384063ec-e079-40e2-a05e-

The optical transfer function measuring equipment described in this International Standard is restricted to that which analyses the radiation distribution in the image plane of the optical imaging system under test. It does not include interferometer-based instruments.

2 Normative references

The following standards contain provisions which, through reference in this text, constitute provisions of this International Standard. At the time of publication, the editions indicated were valid. All standards are subject to revision, and parties to agreements based on this International Standard are encouraged to investigate the possibility of applying the most recent editions of the standards indicated below. Members of IEC and ISO maintain registers of currently valid International Standards.

ISO 9334:1995, Optics and optical instruments — Optical transfer function — Definitions and mathematical relationships.

ISO 9336-1:1994, Optics and optical instruments — Optical transfer function — Application — Part 1: Interchangeable lenses for 35 mm still cameras. ISO 9336-2:1994, Optics and optical instruments — Optical transfer function — Application — Part 2: Lenses for office copiers.

ISO 9336-3:1994, Optics and optical instruments — Optical transfer function — Application — Part 3: Telescopes.

a80687a7724/iso-9334-1 Measuring equipment and equipment environment

4.1 General aspects

4.1.1 Measuring conditions

Any measured OTF depends on the imaging state, I-state, of the imaging system. Thus before making measurements, those parameters which form the I-state of the system shall be identified and the degree to which the I-state depends on those parameters determined. The complete set of parameters that form the I-state shall be set to fixed values. The fixed values represent a particular I-state and are called the measuring conditions.

4.1.2 Accuracy of measurement

The measuring equipment, and the environment in which it is used, shall allow the prescribed measuring conditions to be set and maintained to a precision which is consistent with the required accuracy of measurement. The accuracy of an OTF measurement may be considered as the combination of measurement uncertainties arising from the many separate parameters in the I-state. When a required accuracy of OTF measurement is stated, it shall be apportioned among the known contributing parameters such that a tolerance can be set for each parameter of the I-state. Thus an overall requirement to an accuracy of measurement of \pm 0,05 of the modulation transfer function (MTF) might require, amongst other factors, a temperature stability of the measuring equipment of \pm 1 °C and focal plane setting to 5 \pm µm. The discussion of instrumental and environmental settings in the following subclauses relates to tolerances apportioned from the required OTF measurement accuracy in this manner.

4.2 Environment

The ambient conditions of the OTF equipment shall be kept sufficiently free from influences that can lead to climatic, mechanical or electromagnetic disturbances. The measuring equipment and the atmosphere in the measuring room shall be kept free from dust. moisture and smoke. All optical surfaces shall be protected from the incidence of scratches and finger prints.

tolerances of a diffraction limited lens with circular The temperature shall be kept constant within a stated tolerance and at a suitable value. Humidity shall ISO 93papilgand incoherent illumination that leads to a also be kept within acceptablettlimits.nBothittemperaleg/stand=t0,053MTE3change.4Theawavelength of the light is ture and humidity shall be recorded. Air turbulence 7a7724assumed to be 500 nm. and stratification may affect the measurement and

shall be minimized by use of shielding.

4.2.2 Vibration

Vibration shall be kept to a minimum and the use of basement space is recommended if vibration caused, for example, by machinery, cannot otherwise be avoided. The degree of vibration isolation for a given measuring accuracy depends on the characteristics of the vibration, the measuring method, and the spatial frequency range. If the method consists of measuring the line spread function, a suitable tolerance might be that the movement of the image on the analyser caused by vibrations should not exceed, for example, 1/20 of the width at half maximum intensity of the test slit image.

4.2.3 Electromagnetic disturbances

For some systems, it can be necessary to monitor power supply vibrations and keep these to a tolerable minimum. The influence of external electromagnetic fields and the level of ambient light shall be reduced until they do not affect the measured OTF significantly.

4.3 Measuring equipment

4.3.1 Optical mounts

The basis of any measuring equipment shall be a sturdy optical bench or plate to which mountings for the test target unit, test specimen, image analyser and other auxiliary units can be attached and brought into position with respect to each other to the required accuracy.

Depending on the imaging systems to be tested, different requirements can arise regarding the linearity of adjustments and/or the parallelism of equipment slideways. Deviations from ideal linearity and parallelism requirements shall not cause a greater change of the measured MTF than 1/3 of the permitted or specified measurement accuracy.

4.3.2 Defocusing tolerance

For photographic lenses, the defocusing effects caused by bench misalignment result in errors in the Teh STANDAmeasured MTE which increase with increasing spatial 4.2.1 Temperature and humidity control (standar wavefront aberration. Table 1 gives the defocusing

Values in micrometres

f -number	Defocusing tolerance for spatial frequency (mm ⁻¹)								
	1	5	10	20	50	100			
1	45	9	4,5	2,3	1,0	0,5			
1,4	62	12,5	6,3	3,2	1,4	0,8			
2	89	18	9	4,7	2,0	1,1			
4	180	36,5	18,8	9,8	4,6	3			
8	360	74	39	21,5	12	12,2			
18	720	157	86	54	49	468			
NOTE — For a change of 0.10 in MTF, defocusing tol-									

Table 1 — Defocusing tolerances

erances are twice those shown in the table.

4.3.3 Provision of measuring scales

The measuring equipment shall provide adequate means for determining the positions of test target, system or device under test (test specimen), image analyser and auxiliary systems. These include scales, spindles and dial gauges. Furthermore, means shall be provided to monitor, set or determine all other parameters that form the l-state of the specimen.

4.4 System components

In the following subclauses, details are given concerning the measuring arrangement and its basic elements including the test target unit, test specimen, image analyser and auxiliary imaging systems.

4.4.1 Optical benches

Several arrangements of the measuring equipment are possible, but those in 4.4.1.1 to 4.4.1.4 are recommended.

4.4.1.1 Object and image at finite conjugates

For tests in which object and image are at finite distances from the test specimen, the configurations shown in figure 1 or 2 shall be used. In these arrangements, two of the three basic units (test specimen, test target limit and image analyser) are moved along slideways parallel to one another and perpendicular to the reference axis. Usually the test specimen is fixed and the other two units **moved as shown s.iteh.ai**)

When electrooptic components such as image inten-35:1995 sifiers are to be tested, auxiliary imaging systems are used to produce an image of the test pattern at the input of the test specimen. The image at the output of the test specimen is then relayed to the image analyser. The corresponding arrangement is shown in figure 2.

4.4.1.2 Nominal infinite object conjugate

For tests in which the object conjugate is infinite (i.e. the test target is at the principal focus of a collimator), arrangements similar to that shown in figure 3 shall be used. When off-axis measurements are to be made, the collimator may be rotated by an angle ω about an axis passing through the entrance pupil of the test specimen and perpendicular to the reference axis (see figure 3).

Alternatively, the collimator may be fixed and the test specimen and image analyser rotated together about the entrance pupil. In this case, the mounting fixture for the test specimen and the image analyser slideway are both rigidly fixed to a rotating baseplate (this arrangement is consequently often referred to as the "rotary table" type).

4.4.1.3 Nominal infinite image conjugate

The same arrangement as described in 4.4.1.2 (figure 3) shall be used with the image analyser and test target unit interchanged.

4.4.1.4 Object and image at nominal infinite conjugates

For systems which are tested with both the object and image at infinite conjugates, arrangements similar to those shown in figure 4 shall be used. When offaxis measurements are to be made, the object side collimator with the test target unit should be rotated by an angle ω about an axis passing through the entrance pupil and perpendicular to the reference axis of the test specimen. The image side decollimator together with the image analyser shall be rotated by an angle ω' about an axis passing through the exit pupil and perpendicular to the reference axis and shall be refocused according to the test criteria.

The test target unit shall consist of a source of radiation and a test target.

4.4.2.1 Test target

Depending on the characteristics of the test specimen, several different types of test target may be used. Circular apertures, slits, edges, gratings and self-luminous test targets such as incandescent wires are commonly used. The spatial frequency spectrum of the test target used for the OTF measurement shall be known with an accuracy that is determined by the required measuring accuracy. The actual frequency spectrum of the test target usually differs from its ideal (geometrically predicted) spectrum. If the actual spectrum cannot be measured, precautions shall be taken to ensure that the target is as close as necessary to the specified geometry.







Figure 2 — Schematic setup for image intensifiers







Figure 4 — Schematic test setup: object and image at infinity